Center for Frontiers in Nuclear Science

Workshop

Using Muon Beams from Backscattered Photons on Targets for Various Studies

Organizers:

Ethan Cline, CFNS/Stony Brook Paul Gueye, FRIB/Michigan State Sekazi K. Mtingwa, InCREASE/TriSEED LLC

Utility of Muons

Charged Lepton Flavor Violation

Muon physics and PSI muon beam lines & future developments

A. Papa, 2020 Workshop: Physics Opportunities with the Gamma Factory

https://indico.mitp.uni-mainz.de/event/214/

	Current upper limit	Future sensitivity
$\mu ightarrow e \gamma$	4.2 x 10 ⁻¹³	~ 4 x 10 ⁻¹⁴
$\mu \rightarrow eee$	1.0 x 10 ⁻¹²	~1.0 x 10 ⁻¹⁶
$\mu N \to e N'$	7.0 x 10 ⁻¹³	few x 10 ⁻¹⁷

A Future Muon-Ion Collider at Brookhaven National Laboratory E. Cline, '21 Snowmass

https://indico.cern.ch/event/1072533/contributions/4779239/attachments/2436049/4172090/mup.pdf



Physics Potential of a TeV Muon-Ion Collider D. Acosta *et al.,* Snowmass '21

https://indico.cern.ch/event/1072533/contributions/4779228/attachments/2435658/4171607/DIS-MuIC-Acosta2.pdf



Bending radius of RHIC tunnel: **r = 290m**

Achievable muon beam energy: 0.3Br

	Parameter	1 (aggressive)	2 (realistic)	3 (conservative)	
	Muon energy (TeV)	1.39	0.96	0.73	
	Muon bending magnets (T)	16 (FCC)	11 (HL-LHC)	8.4 (LHC)	
(Muon bending radius (m)		290		
	Proton (Au) energy (TeV)	0.275 (0.11/nucleon)			
	CoM energy (TeV)	1.24 (0.78)	1.03 (0.65)	0.9 (0.57)	
	$\sqrt{s} = 1 \text{ TeV }!$ 7-8X increase over EIC energy				

Gamma Factory Low Emittance Muon Source (Muons from Backscattered Photons on Target) A. Apyan, , 2020 Workshop: <u>Physics Opportunities with the Gamma Factory</u> <u>https://indico.mitp.uni-mainz.de/event/214/</u>

Potential advantages of the Gamma Factory photon-beamdriven muon sources

- Replacing the high-power proton Linac beam by the LHC-driven GF photon-beam may turn out to be an exciting, cost-optimising option for the future muon collider.
- Producing and handling of >1 MW photon beams may turn out be easier than >1 MW proton beams (less power deposited in the target).
- GF source could produce low-emittance muon beams for which the muon-cooling phase may be avoided.
- The almost exact symmetry of the π⁺ / π⁻ and μ⁺ /μ⁻ is assured (contrary to the proton driven sources).
- The above two merits may **facilitate** the design of the **muon collider**.

EIC Electron Beam Parameters (from EIC Design Study)

Parameter	hadron	electron	
Center-of-mass energy [GeV]	104.9		
Energy [GeV]	275	10	
Number of bunches	1160		
Particles per bunch [10 ¹⁰]	6.9	17.2	
Beam current [A]	1.0	2.5	
Horizontal emittance [nm]	9.6	20.0	
Vertical emittance [nm]	1.5	1.2	
Horizontal β -function at IP β_x^* [cm]	90	43	
Vertical β -function at IP β_{γ}^{*} [cm]	4.0	5.0	
Horizontal/Vertical fractional betatron tunes	0.305/0.31	0.08/0.06	
Horizontal divergence at IP $\sigma_{x'}^*$ [mrad]	0.103	0.215	
Vertical divergence at IP $\sigma_{y'}^*$ [mrad]	0.195	0.156	
Horizontal beam-beam parameter ξ_x	0.014	0.073	
Vertical beam-beam parameter ξ_y	0.007	0.1	
IBS growth time longitudinal/horizontal [hr]	3.4/2.0	-	
Synchrotron radiation power [MW]	-	9.0	
Bunch length [cm]	6	2	
Hourglass and crab reduction factor [16]	0.86		
Luminosity $[10^{34} \mathrm{cm}^{-2} \mathrm{sec}^{-1}]$	1.0		

Calculation of Rate of Photon Production

When $\omega_1 \ll E_e$, as in our case, we have the approximation

$$\omega_2 \approx \frac{4\gamma^2 \omega_1}{1 + 4\gamma^2 \frac{\omega_1}{E_e}}.$$

Unpolarized Total Cross Section

Following Landau, Lifshitz, Berestetskii and Pitaevskii [5], we set

$$x_1 = 2\gamma \frac{\omega_1}{E_0} (1 - \beta \cos \phi_1).$$

The total unpolarized Compton cross section σ_C^{unp} is then

$$\sigma_C^{unp} = 2\pi r_0^2 \frac{1}{x_1} \left[\left(1 - \frac{4}{x_1} - \frac{8}{x_1^2}\right) \ln(1 + x_1) + \frac{1}{2} + \frac{8}{x_1} - \frac{1}{2(1 + x_1)^2} \right],$$

where $r_0 = 2.81794 \times 10^{-15}$ m is the classical electron radius.

To include polarization effects, one write can write [6]

$$\sigma_C = \sigma_C^{unp} + 2\lambda_e P_c \sigma_1, \tag{5}$$

where λ_e is the mean electron helicity ($|\lambda_e|^2 \leq \frac{1}{2}$), P_c is the Stokes parameter that gives

the degree of photon circular polarization given by

$$P_c = \frac{(I_L - I_R)}{I_0},$$
 (6)

with I_L , I_R and I_0 being the left circularly polarized, right circularly polarized and total photon intensities. Finally,

$$\sigma_1 = \frac{2\sigma_0}{x_1} [(1 + \frac{2}{x_1})\ln(1 + x_1) - \frac{5}{2} + \frac{1}{1 + x_1} - \frac{1}{2(1 + x_1)^2}], \tag{7}$$

with $\sigma_0 = \pi(\frac{e^2}{m_e c^2}) = 2.5 \times 10^{-29} \text{ m}^2.$

Rate of Backscattered Photons

From the luminosity L, the rate of backscattered photons R is simply

$$\frac{dN}{dt} = \sigma_C L. \tag{9}$$

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We use the Suzuki formula [8], where

$$L = N_e N_{ph} f \frac{\cos(\frac{\phi}{2})}{2\pi} \frac{1}{\sqrt{\sigma_{ye}^2 + \sigma_{yph}^2} \sqrt{(\sigma_{xe}^2 + \sigma_{xph}^2) \cos^2(\frac{\phi}{2}) + (\sigma_{ze}^2 + \sigma_{zph}^2) \sin^2(\frac{\phi}{2})}}, \quad (8)$$

where N_e is the number of electrons in a bunch, N_{ph} is the numbers of photons in a laser

pulse, f is the electron-photon bunch collision frequency, ϕ is two times the crossing angle of the lines defined by the incident electron and photon momenta, and the σ 's define the rms sizes of electron and photon beam dimensions at the interaction point, with z being the longitudinal direction according to Suzuki's notation. The electron rms beam sizes

Laser Parameters

The frequency f at which electron bunches come into the interaction point with the laser pulses is equal to the number of electron bunches in the storage ring (1,160) times the revolution frequency of the electrons around the circumference (3,833.94 meters), or

$$f = \beta c \frac{1160}{3833.94} = 90.7 \,\mathrm{MHz}.$$
 (10)

Müller *et al.* have reported developing a laser system centered at 1046 nm wavelength λ , 254 fs pulse duration, 80 MHz pulse repetition rate, and 10.4 kW average output power P [7]. We note that this is not quite at the 90.7 MHz rep rate for our application; however, that gap should be closed in the near future. Thus, we will assume a laser pulse rep rate of 90.7 MHz.



Letter

Optics Letters

10.4 kW coherently combined ultrafast fiber laser

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An ultrafast laser delivering 10.4 kW average output power based on a coherent combination of 12 step-index fiber amplifiers is presented. The system emits close-totransform-limited 254 fs pulses at an 80 MHz repetition rate, and has a high beam quality ($M^2 \le 1.2$) and a low relative intensity noise of 0.56% in the frequency range of 1 Hz to 1 MHz. Automated spatiotemporal alignment allows for hands-off operation. © 2020 Optical Society of America

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and intensity beam splitters [11]. For Gaussian beams, filledaperture combining is more efficient and hence preferred over tiled-aperture combining at theoretical maximum efficiencies of 100% and 68% [12]. In the filled-aperture schemes, intensity beam splitters offer some practical advantages, such as lower coating absorption compared to polarization beam splitters, lower cost than diffractive optical elements, and easy replacement in the case of damage, leading to the demonstration of a 3.5 kW average-power ultrafast laser [11].

In this contribution, the successor of the system described in Ref. [11] is presented, demonstrating improvement in all

E_e (GeV)	10	20	30	40	50
ω_2 (GeV)	1.54	5.33	10.59	16.84	23.81
$\sigma_{C}~(imes 10^{-25}~{ m cm}^2)$	5.48	4.74	4.25	3.89	3.63
$L (imes 10^{38} \text{ cm}^{-2} \text{-sec}^{-1})$	1.04	1.04	1.04	1.04	1.04
$R \ (imes 10^{13} \ { m sec}^{-1})$	5.72	4.95	4.43	4.06	3.78

TABLE II. Output Parameter Values vs. E_e

Future Possibilities

- Parasitic studies of muon production from backscattered photons at the EIC, similar to GF studies at CERN
- Ascertain the degree of muon beam cooling needed from backscattered photons on targets
- Parasitic mu to e studies of CLFV at the EIC
- Possibility of CERN GF/EIC partnership for photon beam studies
- Studies of plasma wakefield acceleration of muon beams as a step towards a mu+/mu- collider